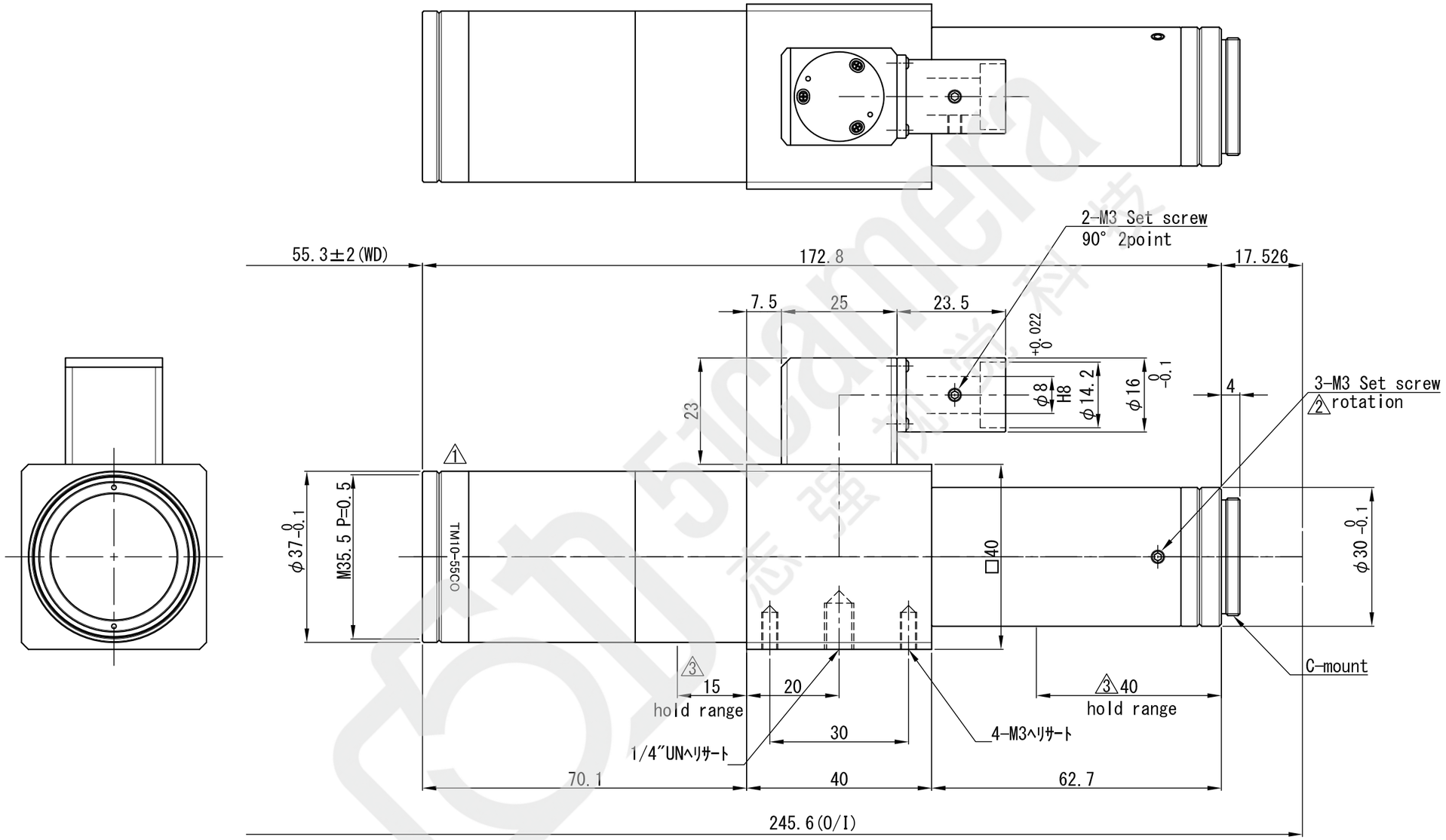

NO.×箇所	REVISION 訂正事項	DATE	NAME
△×			
△×			
△3 × 2	ﾎｰﾙﾄﾞ範囲追加	'20.10.08	R.H.
△2 × 1	rotation表記追加	'19.03.03	T.F.
△1 × 1	彫刻(VS-)削除	16.09.08	M.M.

APPROVED	CHECKED
T.A.	T.M.
DESIGNED	DRAWN
T.A.	S.K.

MATERIAL 材料	–	CHAMFER 一般面取	–	QUANTITY 個数
TREATMENT 処理	–	FINISHING 仕上	–	–
TREATMENT CONTACT 処理接点	–	DECENTRATION 偏芯	–	

TOLERANCES	A	B	C	S
OVER 250 UP TO 1000	±0.3	±0.5	±1.0	±0.2
OVER 63 UP TO 250	±0.2	±0.3	±0.6	±0.15
OVER 16 UP TO 63	±0.1	±0.2	±0.4	±0.1
OVER 0 UP TO 16	±0.05	±0.1	±0.2	±0.1

UNIT(mm)

SCALE 1 / 1

DATE '11.12.26

ANGLE 角度 –

METHOD 図法

REMARK 適用（機種名） VS-TM10-55CO

NAME DRAWING / 外観図

DRAW NO. ODTC0430A4